



Information and Control Global Technical Committee

Japan TC Chapter Meeting

Japan Standards Spring Meetings 2025
Friday, April 18, 2025
Official Virtual TC Chapter Meeting & SEMI Japan office Room1 [Hybrid]
1:30pm - 4:30pm JST

AGENDA

1.0 Welcome / Call to Order

- 1.1 Introductions
- 1.2 Meeting Reminders (*Membership Requirement, Antitrust and Intellectual Property Reminders, Effective Meeting Guidelines*)
- 1.3 Agenda Review

2.0 Review of Previous Meeting Minutes

3.0 Liaison Report

- 3.1 China
- 3.2 Korea
- 3.3 North America
- 3.4 Taiwan
- 3.5 JRSC
- 3.6 GCS

4.0 Staff Report

5.0 Ballot Review

#	When	TF	Details
7330	Cycle 2 2025	JA I&C Maintenance Task Force	Line Item Revision to SEMI E178-0120 GUIDE FOR EDA FREEZE VERSION

6.0 Subcommittee & Task Force Reports

- 6.1 GEM300 TF
- 6.2 Japan I&C Maintenance TF
- 6.3 Diagnostic Data Acquisition (DDA) TF
- 6.4 Fab & Equipment Information Security Task Force

7.0 Old Business

- 7.1 Project Period Review
- 7.2 5-Year Review

8.0 New Business

- 8.1 SNARF Approval
 - 8.1.1 SNARF for Line Item Revision to SEMI E170-0520: SPECIFICATION FOR SECURED FOUNDATION OF RECIP MANAGEMENT SYSTEM (SFORMS) and SEMI E170.1-0520: SPECIFICATION FOR SECS-II PROTOCOL FOR SECURED FOUNDATION OF RECIP MANAGEMENT SYSTEM
- 8.2 Ballot Submission Approval



8.2.1 Line Item Revision to SEMI E170-0520: SPECIFICATION FOR SECURED FOUNDATION OF RECIP MANAGEMENT SYSTEM (SFORMS) and SEMI E170.1-0520: SPECIFICATION FOR SECS-II PROTOCOL FOR SECURED FOUNDATION OF RECIP MANAGEMENT SYSTEM

8.2.2 SNARF 7334: Line Item Revision to SEMI E174-0819 SPECIFICATION FOR WAFER JOB MANAGEMENT (WJM)

9.0 Action Item Review

9.1 Open Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
		<i>None</i>

9.2 New Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>

10.0 Next Meeting and Adjournment